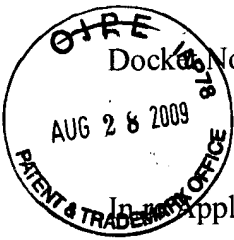


08-31-09

JFW



Docket No.: 085027-0106

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Application of

Hui-Mei Chen, et al.

Application No.: 10/786,807

Filed: February 25, 2004

For: METHOD FOR IMPROVING SEMICONDUCTOR WAFER TEST ACCURACY

: Customer Number: 41552  
:  
: Confirmation Number: 89518  
:  
: Group Art Unit: 2822  
:  
: Examiner: AU, BAC H  
:

**TRANSMITTAL OF POWER OF ATTORNEY**

Mail Stop  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a Power Of Attorney to Prosecute Applications Before the USPTO, together with a Statement Under 37 CFR 3.73(b), which revokes all previous powers of attorney given in the above-identified application and associates the application with Customer Number 89518.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

Dennis A. Duchene  
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**Date: August 28, 2009**

**Please recognize our Customer No. 89518  
as our correspondence address.**

08-31-09



**CERTIFICATE OF MAILING BY EXPRESS MAIL(37 CFR § 1.10)**

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Date of Deposit: August 28, 2009

I hereby certify that this paper or fee is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR § 1.10 on the date indicated above and is addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

  
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SOPHIA CUADRA